



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Applicants: Stefan Mohrdiek Serial No: 10/049,886 Filed: May 20, 2002

Title:

STABILIZED LASER DEVICE

Art Unit: 2881 Examiner: Unknown

POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST (REVOCATION OF PRIOR POWERS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The assignee of the entire right, title and interest of the above identified patent application, hereby revokes all powers of attorney previously given and hereby appoints the following attorneys to prosecute and transact all business in the Patent and Trademark Office connected with the above referenced application.

Mark D. Saralino, Registration No. 34,243

Send correspondence and direct telephone calls to:

Mark D. Saralino, Esq. RENNER, OTTO, BOISSELLE & SKLAR 1621 Euclid Avenue, 19th Floor Cleveland, Ohio 44115

> Tel: 216-621-1113 Fax: 216-621-6165

The undersigned has reviewed all the documents in the chain of title of the patent application identified above and, to the best of the undersigned's knowledge and belief, title is in the assignee identified below.

A statement under 37 CFR 3.73(b) is submitted herewith.

The undersigned further declares that he is empowered to act on behalf of the assignee, and that all statements made herein of his own knowledge are true, and that all statements made on information and belief are believed to be true; and further, that these statements are made with the knowledge that willful false statements, and the like so made, are punishable by fine or imprisonment, or both, under Section 1001, Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

BOOKHAM TECHNOLOGY PLC

Date: 2 June 2003

Intellectual Property Manager

Z:\SEC154\MDS\ABAC\P103us\POA Revocation.wpd;POW-ASS.FRM (9/96)



PTO/SB/96 (08-00)
Approved for use through 10/31/2002. OMB 0651-0031
U.S.Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

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Docket No.ABACP0103US

STATEMENT UNDER 37 CFR 3.73(b)

Applicant/Patent Owner: Stefan Mohrdie	ek
Application No./Patent No.: 10/049,886	Filed/Issue Date: May 20, 2002
Entitled: STABILIZED LASER SOURCE	
BOOKHAM TECHNOLOGY PLC	a Corporation ,
(Name of Assignee)	(Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)
-1-4 4b4 14 1	
states that it is:	
1. The assignee of the entire right, title, a	
2. an assignee of less than the entire rig The extent (by, percentage) of its own	nership interest is%
in the patent application/patent identified abo	ove by virtue of either:
A. [] An assignment from the inventor(s) of was recorded in the United States Parwhich a copy thereof is attached.	f the patent application/patent identified above. The assignment atent and Trademark Office at Reel, or for
OR	'
assignee as shown below:	f the patent application/patent identified above, to the current
	To: Nortel Networks Corp.
Reel <u>012910</u> , Frame <u>06</u>	the United States Patent and Trademark Office at , or for which a copy thereof is attached;
2. From: Nortel Networks Corp	p. To: BOOKHAM TECHNOLOGY PLC
The document was recorded in t Reel, Frame	the United States Patent and Trademark Office at, or for which a copy thereof is attached.
3. From:	
The document was recorded in t	the United States Patent and Trademark Office at 5, 6, or for which a copy thereof is attached.
[] Additional documents in the char	ain of title are listed on a supplemental sheet.
[K] Copies of assignments or other document [NOTE: A separate copy (i.e., the original must be submitted to Assignment Divisior recorded in the records of the USPTO. Se	l assignment document or a true copy of the original document) n in accordance with 37 CFR Part 3, if the assignment is to be
	w) is authorized to act on behalf of the assignee.
2 fm 200 3	Haydn Jones
Date	Typed or printed name
	Signature
	Intellectual Property Manager
	Title

Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.



AMENDMENT TO THE PATENT ASSIGNMENT AGREEMENT

This Amendment (this "Amendment"), effective as of November 8, 2002, to the Patent Assignment Agreement made on November 8, 2002 (the "PAA") is hereby made by and among NORTEL NETWORKS CORPORATION, a corporation duly incorporated under the laws of Canada, having its executive offices at 8200 Dixie Road, Suite 100, Brampton, Ontario L6T 5P6 Canada, and each of its subsidiaries that are listed on the signature pages hereto (collectively, the "Assigning Parties") and BOOKHAM TECHNOLOGY PLC, a public limited company incorporated under the laws of England and Wales having its executive offices at 90 Milton Park, Abingdon, Oxfordshire OX14, 4RY United Kingdom (the "Assignee") (each of the Assigning Parties and Assignee, a "Party" and, collectively, the "Parties").

WHEREAS, the Parties, having entered into the PAA, desire to amend the PAA to update the schedule of patents, patent applications and invention disclosures attached thereto.

NOW THEREFORE, in consideration of the foregoing premises and the mutual terms and conditions set forth herein, and for U.S. \$1.00 (ONE DOLLAR) and other good and valuable consideration, receipt and adequacy of which is hereby acknowledged, the Parties hereby agree that the PAA be, and is, amended as follows:

- 1. Schedule A of the PAA is deleted in its entirety and replaced with the new Schedule A attached hereto.
- 2. Except as expressly amended by this Amendment, all of the terms, covenants and conditions of the PAA shall remain unamended and in full force and effect.
- 3. This Amendment is hereby incorporated in, and forms a part of, the PAA. For the avoidance of doubt, this Amendment shall be governed by and enforced in accordance with the laws of the State of New York, without giving effect to any conflicts of law principles.
- 4. This Amendment shall be binding on, and shall inure to the benefit of, the Parties and their respective successors and assigns.
- 5. This Amendment may be executed in any number of counterparts, each of which shall be deemed to be an original but all of which shall constitute one and the same instrument.

[Remainder of page intentionally left blank]

IN WITNESS WHEREOF, the Parties have duly executed this Amendment as of the date first above written.

Fact

NORTEL NETWORKS CORPORATION Name: Khush Dadyburjor, as Attorney-in-Fact NORTEL NETWORKS INCORPORATED Name: Khush Dadyburjor, as Attorney-in-Fact NORTEL NETWORKS LIMITED Name: Khush Dadyburjor, as Attorney-in-Fact NORTEL NETWORKS PROPERTIES LIMITED Name: Khush Badyburjor, as Attorney-in-

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Name: Khush Dadyburjor, as Attorney-in-
Fact
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COMPONENTS (SWITZERLAND)
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Name: Khush Dadyburjor, as Attorney-in-
Fact

NORTEL NETWORKS OPTICAL COMPONENTS INCORPORATED By: Name: Khush Dadyburjor, as Attorney-in-Fact
NORTEL NETWORKS HPOCS INCORPORATED By: Name: Khush Dadyburjor, as Attorney-in-Fact
NORTEL NETWORKS PHOTONICS PTY LIMITED By: Name: Khush Dadyburjor, as Attorney-in- Fact
NORTEL NETWORKS SHANNON LIMITED By: Name: Khush Dadyburjor, as Attorney-in- Fact

BOOKHAM TECHNOLOGY PLC

By:___ Name: Title:

On this 60 day of December, 2002, before me appeared 60 free act on his/her own who signed this instrument, who acknowledged that he/she signed it as a free act on his/her own

On this day of December, 2002, before me appeared who signed this instrument, who acknowledged that he/she behalf or on behalf of Bookham Technology plc with author	e signed it as a free act on his/her own
State of <u>Kingland</u>) County of <u>Charlether</u>) ss.	
Stand Couch.	
STUART P. B. CAPEL SOLICITOR & NOTARY PUBLIC 6 EAST SAINT HELEN STREET ABINGDON, OXON, OX14 5EW TEL: 01235 - 523411	
FAX: 01235 - 533283	

SCHEDULE A

Disc	Disclosure tritle	Ci	v Serial No.	PatentiN		2 Allimyenines with	Application rife
7000 S	THE RESIDENCE OF THE PARTY OF T	CALL COL			Status	Depution 1	and the state of t
10289R	O PHOTODETECTOR WIT SPECTRALLY EXTENDE RESPONSIVITY		2,269,298				PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY
10289R	O PHOTODETECTOR WITH SPECTRALLY EXTENDE RESPONSIVITY		09/294,114	6,222,200			PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY
10412R0	D EXTERNAL CAVITY LASER	US	09/688,873				EXTERNAL CAVITY LASER USING ANGLE-TUNED FILTER AND METHOD OF MAKING SAME
10413ID	COMPOUND GRADED INDEX LENSES	US	09/750,874				FIBRE TERMINATION COMPOUND GRADED INDEX LENSES
10485RC	D ELECTRICALLY CONTROLLED OPTICAL ATTENUATOR WITH COPLANAR ELECTRODE		09/726,409				ELECTROCHROMIC OPTICAL ATTENUATOR
10509RC	ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS		09/472,121	6,287,401			ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS
10509RC	FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS	CA	2,328,279				ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS
11006ID	MODULATOR ASSEMBLIES	US	09/496,917				MODULATOR ASSEMBLIES
11920ID	PUMPED OPTICAL AMPLIFICATION DEVICE	US	09/557,891				PUMPED OPTICAL AMPLIFICATION DEVICE
11945ID	A RAMAN FIBRE LASER	US	09/573,238				A RAMAN FIBRE LASER
11954ID	A RAMAN FIBRE LASER	us	09/573,236				A RAMAN FIBRE LASER
12242RO	INVERTED INP/INGAAS AVALANCHE PHOTODIODE	US	09/733,060				EPITAXIALLY GROWN AVALANCHE PHOTODIODE
12339ID	OPTICAL FIBER DEVICE	us	09/653,985		~		OPTICAL FIBER DEVICE
12349RO	COMPACT CHIP LABELING USING STEPPER TECHNOLOGY.	CA	2,320,612				COMPACT CHIP LABELING USING STEPPER TECHNOLOGY
12349RO		υs	09/688,366				COMPACT CHIP LABELING USING STEPPER TECHNOLOGY
12526RO	SELF ADJUSTING APPARATUS FOR GRIPPING AND MICRO- MANIPULATING CERAMIC SUBSTRATES	US	09/660,542	6,409,241			APPARATUS FOR GRIPPING CERAMIC SUBSTRATES
12615ID	PACKAGING ATMOSPHERE AND METHOD OF PACKAGING A MEMS DEVICE	US	09/676,256				PACKAGING ATMOSPHERE AND METHOD OF PACKAGING A MEMS DEVICE
12634RO	BE DOPING OF INP	US	09/741,350				STRUCTURE AND METHOD FOR DOPING OF III-V COMPOUNDS
	PRINT QUALITY TEST STRUCTURE FOR DEVICE MANUFACTURING.	US	09/667,620				PRINT QUALITY TEST STRUCTURE FOR LITHOGRAPHIC DEVICE MANUFACTURING
12686ID	GLASS FIBER FIXATIVE AND FIXING PROCESS	US	09/698,800				GLASS FIBER FIXATIVE AND FIXING PROCESS
12715RO	METHOD OF MAKING GRATINGS ON TUNABLE LASER DEVICES	US	09/667,622				METHODS FOR MAKING PATTERNS IN RADIATION SENSITIVE POLYMERS

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No					Status	Cop Nos	Application title was
12800A	FILTER			5,930,44	1		SPLIT-BEAM FOURIER FILTER
1284110	TRANSMITTER						INTEGRATED OPTICAL TRANSMITTER
12847R	HETEROSTRUCTURE LASER CONFINEMENT LAYER	. C/	2,328,641			·	CONFINEMENT LAYER OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
12847R0	D BURIED HETEROSTRUCTURE LASER CONFINEMENT LAYER	US	10/014,807				CONFINEMENT LAYER OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
12849ID	OPTICAL AMPLIFIER METHOD AND APPARATUS	US	09/710,372				OPTICAL AMPLIFIER METHOD AND APPARATUS
12849ID	OPTICAL AMPLIFIER METHOD AND APPARATUS	wc	PCT/GB01/04944				OPTICAL AMPLIFIER METHOD AND APPARATUS
12948ID	OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE	us					OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE
12948ID	OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE	CA	2,364,383				OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE
	AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH		08/726,049	6,041,071			ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER
	AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH		60/004,620				AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH
	AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH		09/532,529				ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER
13144CK	LASER WITH SETTABLE WAVELENGTHS	US	0		Mailed Application	TAYEBATI, PARVIZ (7043-5010439), VAKHSHOORI, DARYOOSH (7068- 5010442)	LASER WITH SETTABLE WAVELENGTHS
13144CK	LASER WITH SETTABLE WAVELENGTHS	US	60/099,252				LASER WITH SETTABLE WAVELENGTHS
13144CK	LASER WITH SETTABLE WAVELENGTHS	US	60/099,308				LASER WITH SETTABLE WAVELENGTHS
13144CK	LASER WITH SETTABLE WAVELENGTHS		09/386,604				LASER WITH SETTABLE WAVELENGTHS
	LASER WITH SETTABLE WAVELENGTHS SINGLE ETALON OPTICAL	CA	2,317,133				LASER WITH SETTABLE WAVELENGTHS
	WAVELENGTH REFERENCE DEVICE	US	60/148,017				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
	WAVELENGTH REFERENCE DEVICE	US	09/636,817				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
	SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE				Nat'l Phase Filed		SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
	WAVELENGTH REFERENCE DEVICE	CA	2,381,662				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13199CK	SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	EP	973357.7				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE

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NOX		首性報			a status.	Pept No.	
13201CI	ODUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	US	60/148,148				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201C	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE		PCT/US00/2190	5	Nat'l Phase Filed		DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201CF	ODUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	US	09/636,807				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201CF	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	CA	2,381,665				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201Ck	OPTICAL WAVELENGTH REFERENCE DEVICE	EP	00957375.9				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13391RC	INTEGRATED OPTICALLY PUMPED EDGE EMITTING SEMICONDUCTOR LASER	1	09/987,785				MONOLITHICALLY INTEGRATED OPTICALLY-PUMPED EDGE- EMITTING SEMICONDUCTOR LASER
13417RC	GRATING ETCHING WITH INP MASKING	US	09/750,124				METHOD OF ETCHING PATTERNS INTO EPITAXIAL MATERIAL
13444CK	MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS	US	09/859,938				MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS
13444CK	MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS	WO	PCT/US01/14918				MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS
13494ID	METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN	US	09/821,580				METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS
13494ID	METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN	EP	02251194.3				METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS
13494ID	METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN	CA	2,374,557				METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS
13495ID	OPTICAL MODULATORS	US	09/679,165	6,377,717			OPTICAL MODULATORS
13502RO	ANGLED OUTPUT BALL TAPERED OPTICAL FIBER TERMINATION	US	09/735,571				OPTICAL FIBER TERMINATION
13524RO	A STATISTICAL MODEL USED TO CONTROL THE LASING WAVELENGTH OF SEMICONDUCTOR LASERS	US	10/196,956		•		A METHOD AND SYSTEM FOR FABRICATING SEMICONDUCTOR LASERS
13544RO	SEMICONDUCTOR LASERS	US	10/141,914				SEMICONDUCTOR LASER
13584RO	ELECTRODE METAL TERMINATION FOR REDUCED LOCAL HEATING	US	09/709,646				ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE
13584RO	TERMINATION FOR REDUCED LOCAL HEATING	CA	2,361,683				ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE
13584RO	TERMINATION FOR REDUCED LOCAL HEATING	EP	01309541.9				ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE
13591ID	OPTICAL MODULATORS	GB	0031241.3				OPTICAL MODULATORS

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NO.		11111			Status	Puept Nos	
135911		WC	PCT/GB01/055	32			OPTICAL MODULATOR
136141	OPTICAL PULSE GENERATION	US	09/993,849				OPTICAL PULSE GENERATION
1361410	OPTICAL PULSE GENERATION	WC	PCT/GB02/0366	34			OPTICAL PULSE GENERATION
13721R	AN NON-DESTRUCTIVE AND FAST WAY TO DETECT DIFFUSION DEPTH AND UNIFORMITY CROSS A WAFER	US	0		Mailed Application	QIAN, YAHONG (C115-0531819,1), AN SERGUEI (5C33- 0510038,1)	AN NON-DESTRUCTIVE AND FAST WAY TO DETECT DIFFUSION DEPTH AD UNIFORMITY CROSS A WAFER
13813R0	DI HIGH POWER LASER DIODE AND METHOD OF FABRICATION THEREOF	US	10/141,862				MONOLITHICALLY INTEGRATED HIGH POWER LASER OPTICAL DEVICE
13816RC	APPARATUS FOR MONITORING THE OUTPUT POWER OF DIODE LASERS AND MODULATORS				Unfiled		52400
14224ID	ISOLATION OF MICROWAVE TRANSMISSION LINES	US	10/032,416				ISOLATION OF MICROWAVE TRANSMISSION LINES
14404RC	HYBRID CONFINEMENT LAYERS OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER	US	10/027,229				HYBRID CONFINEMENT LAYERS OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
14429ID	OPTICAL BEAM SAMPLING MONITOR	US	10/006,509				OPTICAL BEAM SAMPLING MONITOR
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	CA	2,292,769				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	EP	99919257.8				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	JP	11-552490				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	US	09/063,173	6,204,560			TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METHOD
	DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	KR	0-1999-7012042				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	WO F	PCT/EP99/02665		Nat'l Phase Filed		A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD

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ANON					Status	eral Edge Colors	
14433J	D TITANIUM NITRIDE DIFFUSION BARRIER FO USE IN NON-SILICON TECHNOLOGIES AND METHOD	R	0			DAETWYLER, ANDREAS (- GPS4097856), DEUTSCH, URS (EXTR-GPS4097859) HARDER, CHRISTOPI (AA54-5050202), HEUBERGER, WILHELM (EXTR-GPS4097866), LATTA ERNST-EBERHARD (EXTR-GPS4097878), JAKUBOWICZ, ABRAN (-GPS4097872), OOSENBRUG, ALBERTUS (- GPS4097875)	H
14434JE	SOURCE	EP	99810837.7				STABILIZED LASER SOURCE
14434JE	STABILIZED LASER SOURCE	US	10/0498889				STABILIZED LASER SOURCE
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT		99811030.8				SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT		PCT/IB00/01530		Nat'l Phase Filed		SUPPORTING STRUCTURE FOR OPTICAL FIBER FIXING AND SUBMICRONFINE ALIGNMENT
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT		PCT/IB00/01530		Nat'l Phase Filed		SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	CA	2,390,916		Nat'l Phase Filed		SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT
14480RO	GAIN COUPLED DISTRIBUTED FEEDBACK LASER USING SELF- ASSEMBLED QUANTUM DOTS				Unfiled		
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE	US	09/852,994				HIGH POWER SEMICONDUCTOR LASER DIODE
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE	CA	2,385,653				HIGH POWER SEMICONDUCTOR LASER DIODE
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE	EP	2405380.3				HIGH POWER SEMICONDUCTOR LASER DIODE
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE	JP	2002-134066				HIGH POWER SEMICONDUCTOR LASER DIODE
14551JD	CARRIER DESIGN FOR MODULES WITH HIGH POWER LASER DIODES	US	10/026,150				HIGH POWER LASER CARRIER
14552JD	ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS	US	09/993,824				ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS
14592ID	OPTICAL COMPONENT ALIGNMENT TECHNIQUE	US	10/024,972				GIMBALLED LENS MOUNT AND ALIGNMENT ASSEMBLY FOR A SENSITIVE OPTICAL ALIGNMENT
14676RO	ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN- COUPLED GRATINGS	US	60/334,013				ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN-COUPLED GRATINGS

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14676F	RO ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN- COUPLED GRATINGS	US	10/025,866		Slaius	TO GO BY OF S	ENHANCED LINK OPERATION O DIRECTLY MODULATED LASER: COUPLED-COUPLED GRATINGS
146811	COMPENSATION AND ALIGNMENT FOR OPTICAL DEVICES	US	10/032,421				THERMAL COMPENSATION AND ALIGNMENT FOR OPTICAL DEVICES
14716R	WAVEGUIDE MODE STRIPPER FOR INTEGRATED OPTICAL COMPONENTS	US	10/073,101				WAVEGUIDE MODE STRIPPER FOR INTEGRATED OPTICAL COMPONENTS
14794R	O A METHOD FOR MAKING FLOATING GRATINGS	US	10/259,745				METHOD AND APPARATUS FOR FLOATING GRATINGS IN DFB (DISTRIBUTED FEEDBACK)
14854R(A METHOD FOR MINIMIZING CROSSTALK DUE TO LASER WAVELENGTH VARIATIONS WITH NON- IDEAL FILTERS				Unfiled		LASERS
14864R0	POLARIZATION AND WAVELENGTH INDEPENDENT MHZ SPEED OPTICAL ATTENUATOR	US	10/190,592				CURRENT TUNED MACH- ZEHNDER OPTICAL ATTENUATOR
14942RC	OPTICAL PULSE GENERATOR	US	10/116,168				RE-CIRCULATING OPTICAL PULSE GENERATOR
	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)		10/098,446				MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPONENTS COMPRISING MICRO-MIRRORS
	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)		10/098,446			·	MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPO ENTS COMPRISING MICRO-MIRRORS
15004RO	MICRO MIRRORS (DPMM)	US	10/098,446				MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPONENTS COMPRISING MICRO-MIRRORS
15093RO	SEMICONDUCTOR OPTICAL AMPLIFIERS	US	60/414,404				MULTIPLE-CONTACT OPTICAL AMPLIFIERS
15095RO	FREQUENCY IDENTIFICATION WITH A FREQUENCY LOCKER	US	10/108,856				FREQUENCY IDENTIFICATION WITH FREQUENCY LOCKER
15113CK	TEMPERATURE STABILITY OF FREQUENCY LOCKER IN OPTOELECTRONIC MODULES	US	10/165,465				WAVELENGTH STABILIZED OPTICAL DEVICE
	NEW STRAIGHT-FLARED- STRAIGHT WAVEGUIDE DESIGN	US	10/131,335				HIGH POWER SEMICONDUCTOR LASER DIODE AND METHOD FOR MAKING SUCH A DIODE
15117JD	WITH IMPROVED WAVELENGTH STABILITY	US	0				*PUMP LASER DIODE WITH IMPROVED WAVELENGTH STABILITY
15138ID	AN IMPROVED METHOD FOR TERMINATING AN OPTICAL WAVEGUIDE INTO AN OPTICAL COMPONENT	US	10/161,523				AN IMPROVED METHOD FOR TERMINATING AN OPTICAL WAVEGUIDE INTO AN OPTICAL COMPONENT

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15142R					Statu	Sept. No. St.	
	INDEX CONTRAST POLYMER FLEXIBLE WAVEGUIDES		60/352,572				FLEXIBLE POLYMER WAVEGUIDES FOR OPTICAL WIRE BONDS
15142R	INDEX CONTRAST POLYMER FLEXIBLE WAVEGUIDES	US	60/352,572				FLEXIBLE POLYMER WAVEGUIDES FOR OPTICAL WIRE BONDS
15150R	INTEGRATING A LASEF WITH A WAVEGUIDE IN SINGLE EPITAXIAL GROWTH STEP				Mailed Applicati		N OPTICAL DEVICES IN A SINGL EPITAXIAGROWTH STEP
15150R0	INTEGRATING A LASER WITH A WAVEGUIDE IN SINGLE EPITAXIAL GROWTH STEP	A	0		Mailed Application		N OPTICAL DEVICES IN A SINGLI EPITAXIAGROWTH STEP
15164RC	REAL REFRACTIVE INDEX-GUIDED SELF- ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER.	US	0		Mailed Application	GLEW, RICK (C116- 2819324), REID, BENOIT (5C32- 0531388), LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053568)	A GUIDED SELF-ALIGNED LASE STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15164RO	A DOPANT-INDUCED REAL REFRACTIVE INDEX-GUIDED SELF- ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER.	US	o		Mailed Application	BENOIT (5C32- 0531388), LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55-	A GUIDED SELF-ALIGNED LASEI STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15181ID	LASER TRANSMITTER	us	60/391,648		 	5053568)	LASER TRANSMITTER
15181ID	LASER TRANSMITTER	us	60/391,648				LASER TRANSMITTER
15193RO	OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER	US	60/380,261				OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIF POLARIATION CONVERTER
15193RO	OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER	US			Mailed Application	EL-REFAEI, HATEM (5C33-0273812), JONES, TREVOR (C115-1342592,2), YEVICK, D (EXTR- GPS0380642,2)	OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIATION CONVERTER
15320RO	ELECTRO-OPTIC MODULATOR WITH CONTINUOUSLY ADJUSTABLE CHIRP	US	0		Mailed Application	PROSYK, KELVIN (5C33-0526051), BETTY, IAN (5C33- 0519725)	ELECTRO-OPTIC MODULATOR WITH CONTINUOUSLY ADJUSTABLE CHIRP
	HIGH POWER DISTRIBUTED FEEDBACK LASER				Unfiled		
15386JD	RIDGE WAVEGUIDE LASER DIODE WITH COMPLEX INDEX GUIDING LAYER	US	0		Mailed Application	TRAUT, SILKE (4212- 5050415), SCHMIDT, BERTHOLD (AA54- 5050359,4), SVERDLOV, BORIS (AA54-5050400,1), THIES, ACHIM (4212- 5050409,1)	HIGH POWER SEMICONDUCTOR LASER DIODE AND METHOD FOR MAKING SUCH A DIODE
5389JD	LASER STABILIZATION USING VERY HIGH	T			Unfiled		
	RELATIVE FEEDBACK						

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15390R	O ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE	N US	60/404,166				ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE
15390R	O ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE	V US	60/404,166				ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE
15399J	D A GUIDED SELF-ALIGNE LASER STRUCTURE WIT INTEGRAL CURRENT BLOCKING LAYER		60/390,882				A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15399JI	D A GUIDED SELF-ALIGNEI LASER STRUCTURE WIT INTEGRAL CURRENT BLOCKING LAYER				Mailed Application	LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053568,1), SCHMIDT BERTHOLD (AA54- 5050359,2), REID, BENOIT (5C32- 0531388,2), KNIGHT, D. GORDON (C116- 1529664,1)	A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15502R	A P-SUBSTRATE SELF- ALIGNED LASER STRUCTURE WITH IRON DOPED CURRENT BLOCKING LAYERS				Unfiled	.020007,1)	
15507RC	A MAGNETO-OPTIC NONRECIPROCAL WAVEGUIDE TE/TM MODE CONVERTER IN SEMICONDUCTING MATERIALS				Unfiled		
15558RC	MANUFACTURE OF A GRATING TEMPLATE AND ITS TRANSFER INTO AL (IN, GA)AS MATERIAL USING IN-SITU ETCHING AND REGROWTH INSIDE A GROWTH REACTOR.				Unfiled		
15592RO	ETCHING OF INDEX- OR GAIN-COUPLED GRATINGS INTO INGAASP MATERIAL USING IN-SITU ETCHING IN A GROWTH REACTOR				Unfiled		
15649JD	LASER STRUCTURE WITH LARGE OPTICAL SUPERLATTICE WAVEGUIDE		-		Unfiled	·	
15655RO	HIGH TEMPERATURE OPERATION LASER DIODES				Unfiled		
15656RO	FABRICATION OF A BURIED HETEROSTRUCTURE LASER WITH AN INGAASP ACTIVE LAYER USING IN- SITU ETCHING IN A GROWTH REACTOR		i.		unfiled		
HQ0054	SUPERIMPOSED GRATING WDM TUNABLE LASERS	CA	2,228,683	2,228,683			SUPERIMPOSED GRATING WDM TUNABLE LASERS
HQ0054	SUPERIMPOSED GRATING WDM TUNABLE LASERS	US	09/253,129	6,141,370			SUPERIMPOSED GRATING WDM TUNABLE LASERS

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ID0032		US	08/319,435	5,534,44	2		OPTO ELECTRONIC COMPONENTS
ID0079	SEMICONDUCTOR - SLICE CLEAVING	GB	9216363.3	2 269 268	3		SEMICONDUCTOR - SLICE CLEAVING
ID0079	SEMICONDUCTOR - SLICE CLEAVING	บร	08/093,766	5,393,707			SEMICONDUCTOR - SLICE CLEAVING
ID0094	HYBRID OPTIC SOLUTION	V DE	95307824.3	695 04 280.7			HYBRID OPTIC SOLUTION
ID0094	HYBRID OPTIC SOLUTION	FR	95307824.3	0 713 271			HYBRID OPTIC SOLUTION
ID0094	HYBRID OPTIC SOLUTION	(GB	9423282.4	2 295 265			HYBRID OPTIC SOLUTION
ID0094	HYBRID OPTIC SOLUTION	JP	293046/1995				HYBRID OPTIC SOLUTION
ID0094	HYBRID OPTIC SOLUTION	us	08/560,312	5,668,823			HYBRID OPTIC SOLUTION
ID0134	SEMICONDUCTOR ETCHING PROCESS	FR	94301114.8	0 614 214			SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	GB	94301114.8	0 614 214			SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	DE	69401370.6	69401370.0	6		SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	GB	9303257.1	2 275 364			SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	JP	6-45068				SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	US	08/197,071	5,419,804			SEMICONDUCTOR ETCHING PROCESS
ID0137	PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS	GB	9417975.1	2 293 248			PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS
ID0137	PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS	US	08/507,613	5,574,811			PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS
ID0170	INJECTION LASER AND PHOTOSENSOR ASSEMBLY	US	08/201,473	5,365,534			INJECTION LASER AND PHOTOSENSOR ASSEMBLY
ID0193	FILAMENT COOLER	GB	9404290.0	2 287 244			FILAMENT COOLER
ID0193	FILAMENT COOLER	us	08/388,151	5,568,728			FILAMENT COOLER
ID0199	CO & COUNTER-PUMPED OPTICAL AMPLIFIER	us	08/303,367	5,542,011			CO & COUNTER-PUMPED OPTICAL AMPLIFIER
ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS	us	08/303,374	5,530,580			ELECTRO ABSORPTION OPTICAL MODULATORS
ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS	EP	94306216.6	0 643 317	Nat'l Phase Filed		ELECTRO ABSORPTION OPTICAL MODULATORS
ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS	GB	9417001.6	2 281 785			ELECTRO ABSORPTION OPTICAL MODULATORS

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ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS		94306216.6	694 26 796.1			ELECTRO ABSORPTION OPTICAL MODULATORS
ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS		94306216.6	0 643 317	7		ELECTRO ABSORPTION OPTICAL MODULATORS
ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS		216309/94				ELECTRO ABSORPTION OPTICAL MODULATORS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	DE	94305060.9	694 10 032.3			PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	FR	94305060.9	0 636 912			PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	GB	9315789.9	2 280 544			PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	GB	94305060.9	0 636 912			PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	JP	180288/94				PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	US	08/283,264	5,522,000	·	·	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0237	DIRECT AMPLITUDE MODULATION OF LASERS	US	08/216,301	5,502,741		-	DIRECT AMPLITUDE MODULATION OF LASERS
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	EP	96301377.6	0 732 739	Nat'l Phase Filed		IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	JP	52013/96				IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	US	08/612,314	5,933,707			IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	GB	96301377.6	0 732 739			IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	DE	96301377.6	696 18 264.5			IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING

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ID026	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING		FR 96301377.6	0 732 7	39	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID028	7 POLARISATION- INSENSITIVE OPTICAL MODULATORS	- E	DE 195 28 165.	9		POLARISATION-INSENSITIVE OPTICAL MODULATORS
ID0287	7 POLARISATION- INSENSITIVE OPTICAL MODULATORS		B 9515400.1	2 291 9	79	POLARISATION-INSENSITIVE OPTICAL MODULATORS
ID0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	F	R 9509417	272348	5	POLARISATION-INSENSITIVE OPTICAL MODULATORS
ID0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	U	S 08/510,752	6,275,32	ei	POLARISATION-INSENSITIVE OPTICAL MODULATORS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	EI	95308872.1	0 717 29	7 Nat'l Phas Filed	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	GI	9425022.2	2 296 10	1	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	US	08/570,983	5,570,444	4	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	DE	95308872.1	695 26 563.6		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	GB	95308872.1	0 717 297		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	FR	95308872.1	0 717 297		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	IT	95308872.1	0 717 297		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0311	OPTICAL AMPLIFIER	DE	96308900.8	696 03 935.4		OPTICAL AMPLIFIER
ID0311	OPTICAL AMPLIFIER	EΡ	96308900.8		Nat'l Phase Filed	OPTICAL AMPLIFIER
ID0311	OPTICAL AMPLIFIER	П	96308900.8	0 779 689		OPTICAL AMPLIFIER
ID0311	OPTICAL AMPLIFIER	FR	96308900.8	0 779 689		OPTICAL AMPLIFIER
ID0311	OPTICAL AMPLIFIER	GB	9525766.3	2 308 222		OPTICAL AMPLIFIER
ID0311	OPTICAL AMPLIFIER LASERS	US	08/760,175	5,872,649		OPTICAL AMPLIFIER
ID0348	HERMETIC OPTICAL		PCT/GB96/01406		Nat'l Phase Filed	LAGENG
	FIBRE FEED-THROUGH	GB	9515004.1	2 303 467		HERMETIC OPTICAL FIBRE FEED- THROUGH
ID0384	HERMETIC OPTICAL FIBRE FEED-THROUGH	US	08/684,128	5,664,043		HERMETIC OPTICAL FIBRE FEED- THROUGH

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ID0426	ETALON ARRANGEMENT	F EP	97305110.5				ETALON ARRANGEMENT
ID0426	ETALON ARRANGEMENT	JP	179766/1997				ETALON ARRANGEMENT
ID0426			179766/1997				ETALON ARRANGEMENT
ID0426			2,203,845	2,203,845	<u> </u>		ETALON ARRANGEMENT
ID0426			08/848,337	5,828,689			ETALON ARRANGEMENT
ID0431	SEMICONDUCTOR LASERS	DE	97901693.8	697 00 830.4			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	EP	97901693.8	0 876 696	Nat'l Phase Filed		SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	FR	97901693.8	0 876 696			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	GB	9601703.3	2 309 581			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	GB	97901693.8	0 876 696			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	IT	97901693.8	0 876 696			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	JP	526680/1997				SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	US	09/091,684	6,058,125			SEMICONDUCTOR LASERS
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	EP	97902473.4	0 879 435	Nat'l Phase Filed		SECURING AN OPTICAL FIBRE IN A V-GROOVE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	GB	9602564.8	2 310 052	·		CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	JP	528272/1997				CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	US	08/952,676	5,985,086			CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	DE	97902473.4	697 10 047.2		·	SECURING AN OPTICAL FIBRE IN A V-GROOVE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	П	97902473.4	0 879 435			SECURING AN OPTICAL FIBRE IN A V-GROOVE

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ID0467	CONTROLLED DISPENSI OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	E FR	97902473.4	0 879 435		, Pepik Io≊	SECURING AN OPTICAL FIBRE IN A V-GROOVE
ID0467	CONTROLLED DISPENSI OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	wo	PCT/GB97/00320		Nat'l Phase Filed		CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	JP	507707/1998				SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	US	09/214,634	6,188,118			SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	CA	2,258,178				SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	EP	97933796.1				SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	WO	PCT/GB97/02053		Nat'l Phase Filed		SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	EP	98303274.9				DIRECT AMPLITUDE MODULATION OF LASERS
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	US	08/865,760	5,901,164			DIRECT AMPLITUDE MODULATION OF LASERS
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	CA	2,235,179				DIRECT AMPLITUDE MODULATION OF LASERS
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	JP	146072/1998				DIRECT AMPLITUDE MODULATION OF LASERS
ID0687	OPTICAL TRANSMITTER OUTPUT MONITORING TAP	US	08/984,894	6,124,956			OPTICAL TRANSMITTER OUTPUT MONITORING TAP
ID0691	BONDING RIDGE STRUCTURE LASER DIODES TO SUBSTRATES	US	09/072,810	6,075,800		ı	BONDING RIDGE STRUCTURE ASER DIODES TO SUBSTRATES
ID0764	A REMOVABLY COATED OPTICAL FIBRE	US	09/374,807	6,351,589			REMOVABLY COATED OPTICAL FIBRE
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	EP	98309206.5		·		ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	JP	365470/1998			3	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	US	08/997,752	5,956,437		E	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	CA	2,254,148			. E	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR

DESCRIPTION	
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ID8852 MANUFACTURING OPTICAL FIBRE US 06/736,327 4,608,276 MANUFACTURING FIBRE ID8852 MANUFACTURING OPTICAL FIBRE CA 482,229 1,261,632 MANUFACTURING FIBRE ID8960 OPTICAL FIBRE MANUFACTURE US 06/940,232 4,735,648 OPTICAL FIBRE MANUFACTURE ID9003 COATING OPTICAL FIBRES DE 85306977.1 356 83 25.2 COATING OPTICAL FIBRES ID9003 COATING OPTICAL FIBRES US 06/782,930 4,631,078 COATING OPTICAL ID9003 COATING OPTICAL FIBRES US 06/782,930 4,631,078 COATING OPTICAL ID9003 COATING OPTICAL FIBRES COATING OPTICAL ID9003 COATING OPTICAL FIBRES CA 492,574 1,226,411 COATING OPTICAL ID9004 COATING OPTICAL FIBRES CA 492,574 1,226,411 COATING OPTICAL ID9186 LASER MANUFACTURE US 07/296,946 4,949,352 LASER MANUFAC	FIERS
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	HAVING SLOTTED COP	E	86306868.0	0 216 54	8		OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED COR		217514	217514			OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED COR		07/636,902	RE34,51	6		OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID9379	OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER	US	06/934,440	4,772,086	6		OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER
ID9379	OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER	GB	8530797	2 184 255			OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER
ID9495	LASER ARRAY	DE	87302417.8	376 44 10.	6		LASER ARRAY
ID9495	,	JP	129591/87	2511969			LASER ARRAY
ID9495	LASER ARRAY	US	07/032,779	4,760,580			LASER ARRAY
ID9552	OPTICAL FIBRE CABLES		3883556.8	3883556.8			OPTICAL FIBRE CABLES
ID9552	OPTICAL FIBRE CABLES		88300817.9	0 278 648			OPTICAL FIBRE CABLES
ID9552	OPTICAL FIBRE CABLES		8703255	2 201 008			OPTICAL FIBRE CABLES
ID9552	OPTICAL FIBRE CABLES	US	07/154,866	4,830,459			OPTICAL FIBRE CABLES
1D9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	DE	88306994.0	388 13 01.7			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	FR	88306994.0	0 304 182			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	GB	8719590	2 208 944			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	GB	88306994.0	0 304 182			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	NL	88306994.0	0 304 182			FIBRE TAILED OPTO- ELECTRONIO TRANSDUCER
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ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	US	07/230,057	4,988,159			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9617	EDGE EMITTING LIGHT EMISSIVE DIODE	US	07/239,403	4,937,638			EDGE EMITTING LIGHT EMISSIVE DIODE
ID9661	WAVEGUIDE TO OPTO- ELECTRONIC TRANSDUCER	GB	8823873.8	2 213 957			WAVEGUIDE TO OPTO- ELECTRONIC TRANSDUCER

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ID971	MEASUREMENT OF TH ELECTRICAL RESISTANCE PER	E	690 20 050.1	690 20 050.1		CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
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ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	E FR	90305474.0	0 400 853	3	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH.
ID9715	CONTACTLESS	GB	8912458.0	2 232 260	 	CONTACTLESS MEASUREMENT
	MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH					OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH.
ID9715		JP	141220/1990	2991238	1	CONTACTLESS MEASUREMENT
	MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH					OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
ID9715		US	07/531,791	5,083,090		CONTACTLESS MEASUREMENT
	MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH					OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
ID9716	CARB ON COATING OF	DE	690 10 282.8	0 400 938	 	CARB ON COATING OF OPTICAL
	OPTICAL FIBRES					FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	FR	90305776.8	0 400 938		CARB ON COATING OF OPTICAL FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	GB	9011933.0	2 236 331		CARB ON COATING OF OPTICAL FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	JP.	141221/1990	2866707		CARB ON COATING OF OPTICAL FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	us	07/531,859	5,062,687		CARB ON COATING OF OPTICAL FIBRES
ID9731	BONDING A SEMICONDUCTOR TO A SUBSTRATE	GB	8818522.8	2 221 570		BONDING A SEMICONDUCTOR TO A SUBSTRATE
ID9742	OPTICAL FILTERS	GB	8823078.4	2 223 324		OPTICAL FILTERS
ID9750	DIFFRACTION GRATING	DE	68928711.9	0365125		DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	FR	89308702.3	0 365 125		DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	GB	8821898.7	2 222 891		DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	п	22874/BE/98	0 365 125		DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608		DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608		DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608		DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	US	07/579,081	5,029,981		DIFFRACTION GRATING

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DIFFRACTION GRATING	JP	239789/1989	2889608			DIFFRACTION GRATING
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VAPOUR PHASE PROCESSING	GB	8823233.5	2 223 509			VAPOUR PHASE PROCESSING
MULTICHANNEL CAVITY LASER	DE	89312024.6	689 18 238.4			MULTICHANNEL CAVITY LASER
MULTICHANNEL CAVITY LASER	FR	89312024.6	0 370 739			MULTICHANNEL CAVITY LASER
MULTICHANNEL CAVITY LASER	GB	8827385.9	2 225 482			MULTICHANNEL CAVITY LASER
MULTICHANNEL CAVITY LASER	US	07/625,818	5,115,444			MULTICHANNEL CAVITY LASER
INTEGRATED OPTICS ASYMMETRIC Y- COUPLER	GB	8902391.5	2 227 854			INTEGRATED OPTICS ASYMMETRIC Y-COUPLER
OPTICAL FIBRE CABLE	US	07/544,678	5,082,380			OPTICAL FIBRE CABLE
AERIAL OPTICAL FIBRE CABLE	US	07/596,381	5,050,960			AERIAL OPTICAL FIBRE CABLE
SEMICONDUCTOR OPTICAL SOURCE	GB	8924725.8	2 237 654			SEMICONDUCTOR OPTICAL SOURCE
RING LASER	FR	90309362.3	0 419 059			RING LASER
RING LASER	GB	8921295.5	2 236 426			RING LASER
RING LASER	DE	69003780.5	0 419 059			RING LASER
RING LASER	JP	249922/1990	3004336			RING LASER
RING LASER	US	07/583,590	5,056,096			RING LASER
OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	FR	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	CA	2,013,849	2,013,849			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	DE	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	EP	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	US	07/363,006	4,934,774			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
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WO006	AND METHOD FOR ITS MANUFACTURE		07/501,990	5,035,916			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
WO0068	B OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	GB	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0166	A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM AN OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER		08/710,775	5,703,980			A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM A OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS OF A SEMICONDUCTOR SUBSTRATE		2,209,548				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		97111629.8				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		9-185588				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		08/677,922	5,793,913			A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		09/079,480	6,158,901			A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	US	09/584,792	6,391,214			METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
RE1009	FIBER OPTIC COUPLER	CA	476,580	1,258,787			FIBER OPTIC COUPLER
RE1009	FIBER OPTIC COUPLER	US	07/442,878	4,950,046			FIBER OPTIC COUPLER
RE1037	OPTICAL SIGNAL MODULATORS	CA	507,411	1,257,923			OPTICAL SIGNAL MODULATORS
RE1037	OPTICAL SIGNAL MODULATORS	US	06/856,887	4,730,171			OPTICAL SIGNAL MODULATORS
RO1624	HERMETIC OPTICAL ATTENUATOR	US	06/233,500	4,695,125			HERMETIC OPTICAL ATTENUATOR

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RO18			The first same the same and the first same	1,204,986		Depuilo Se	
RO18	07 DIFFUSION EQUIPMEN	IT US					DIFFUSION EQUIPMENT
				4,493,287			DIFFUSION EQUIPMENT
RO18	STRIPE LASER WITH IMPROVED CHARGE CARRIER CONFINEMENT		06/448,383	4,530,099			A PLANAR NARROW-STRIPE LASER WITH IMPROVED CHARG CARRIER CONFINEMENT
RO188	LIQUID PHASE EPITAX BOAT	Y CA	448,169	1,201,220			MELT DISPENSING LIQUID PHASE EPITAXY BOAT
RO188	LIQUID PHASE EPITAX BOAT	y US	06/583,985	4,574,730			MELT DISPENSING LIQUID PHASE EPITAXY BOAT
RO190	METHOD FOR SCREENING LASER DIODES	CA	447,814	1,196,080			METHOD FOR SCREENING LASER DIODES
RO190	METHOD FOR SCREENING LASER DIODES	US	06/582,956	4,489,477			METHOD FOR SCREENING LASER DIODES
RO194	4 PHASED LINEAR LASER ARRAY	CA	465,981	1,238,707			PHASED LINEAR LASER ARRAY
RO1944	4 PHASED LINEAR LASER ARRAY	US	06/663,424	4,661,962			PHASED LINEAR LASER ARRAY
RO1961	ZINC DIFFUSION INTO INDIUM PHOSPHIDE	CA	495,084	1,290,656			ZINC DIFFUSION INTO INDIUM PHOSPHIDE
RO1961	ZINC DIFFUSION INTO INDIUM PHOSPHIDE	US	07/243,138	4,889,830			ZINC DIFFUSION INTO INDIUM PHOSPHIDE
RO1987	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE	CA	483,077	1,238,973			DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE
RO1987	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE	US	06/673,644	4,660,207			DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE
RO1994	A SURFACE EMITTING LASER	CA	474,029	1,238,971			A SURFACE EMITTING LASER
RO1994	A SURFACE EMITTING LASER	US	06/701,839	4,675,877			A SURFACE EMITTING LASER
RO2005	A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER	US	06/701,707	4,675,876		F	A BRAGG DISTRIBUTED EEDBACK SURFACE EMITTING LASER
RO2005	A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER	CA	474,030	1,238,972		F	A BRAGG DISTRIBUTED EEDBACK SURFACE EMITTING LASER
	AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE	CA	562,885	1,293,179		Al	N INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE
302268	AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE	US	07/179,834	4,859,628		AF	NINTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE

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RO2314		US	07/176,120	4,847,66	MONOLITHIC INTEGRATION OF OPTOELECTRONIC AND ELECTRONIC DEVICES
RO2349	GROWTH OF SEMI- INSULATING INP BY LIQUID PHASE EPITAXY	us	07/201,155	4,849,373	GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY
RO2349	GROWTH OF SEMI- INSULATING INP BY LIQUID PHASE EPITAXY	CA	568,369	1,313,107	GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY
RO2461	OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION	US	07/369,883	4,969,712	OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION
RO2468	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE	CA	2,018,900	2,018,900	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE
RO2468	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE	US	07/385,599	4,953,006	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE
RO2564	LASER DIODE STRUCTURE	FR	91908207.3	0 530 212	LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	DE	91908207.3	691 07 845.9	LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	GB	91908207.3	0 530 212	LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	us	07/522,015	4,989,214	LASER DIODE STRUCTURE
RO2579	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER	US	07/582,464	5,050,953	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER
RO2579	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER	GB	91185124	2 248 968	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER
RO2714	APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS	US	07/996,411	5,350,923	APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	DE	94915483.5	694 08 144.2	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	FR	94915483.5	0 708 930	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION

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MODULATING DEVICES AND METHODS FOR THEIR OPERATION RO2785 OPTICAL PHASE MODULATING DEVICES AND METHODS FOR MODULATING DEVICES AND METHODS FOR AND METHODS FOR THEIR OPERATION RO2786 METHOD OF REDUCING THEIR OPERATION RO2787 METHOD OF REDUCING THEIR OPERATION RO2788 METHOD OF REDUCING THEIR OPERATION RO2789 GAIN COUPLED DFB LASE INDEX COUPLING COMPENSATION RO2799 GAIN COUPLED DFB LASE INDEX COUPLING COMPENSATION RO2809 METHODS AND ASSEMBLES FOR PACKAGING ELECTRONIC DEVICES AND ELECTRONIC DEVICES AND ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE LASER TO THE PACKAGED DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE LASER STO THE PACKAGED DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE LASER STO THE STRUCTURE FOR USING NON EQUAL POWER SPLITTING STRUCTURE FOR IMPROVE STRUCTU	RO278	MODULATING DEVICES AND METHODS FOR THEIR		94915483.5	0 708 930	0		OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR
MODULATING DEVICES AND METHODS FOR THEIR OPERATION RO2788 METHOD OF REDUCING OPERATION RO2788 METHOD OF REDUCING THE THEMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES RO2799 GAIN COUPLED DFB LASER WITH INDEX COUPLING COMPENSATION RO2809 METHODS AND ASSEMBLES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES RO2817 CIRCULAR GRATING US 08/158,543 5,448,581 CIRCULAR GRATING LASER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING RO2879 SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THE HEADS OF COUPLING COUPLING ON EQUAL POWER SPLITTING RO2879 SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THE THRESHOLD CURRENT ON CHANGES IN AMBIENT TEMPERATURE	RO2785	MODULATING DEVICES AND METHODS FOR THEIR		7-504252-95	2691638			
THE THERMALLY INDUCED SHIFT IN THE INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES RO2799 GAIN COUPLED DFB LASER WITH INDEX COUPLING COMPENSATION RO2809 METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES AND LASER STRUCTURE ROAT COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES AND LASERS RO2817 CIRCULAR GRATING LOS 08/158,543 5,448,581 CIRCULAR GRATING LASERS RO2875 CHIRP CONTROL OF A MACH ZEHNDER AMACH ZEHNDER OFTICAL FUNDER OFTICAL FIBERS TO THE PACKAGEN DEVICES AND LASERS RO2875 CHIRP CONTROL OF A MACH ZEHNDER SPLITTING SPLITTING ROAT SEMILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE RO2879 SEMICONDUCTOR LASER STRUCTURE FOR IMPROVE STRUCTURE FOR IMPROVE STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE	RO2785	MODULATING DEVICES AND METHODS FOR THEIR		08/091,708	5,363,457			
LASER WITH INDEX COUPLING COMPENSATION RO2809 METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES AND RO2817 CIRCULAR GRATING LASERS RO2817 CIRCULAR GRATING LASERS RO2875 CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING RO2879 SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE THEMPERATURE OS/158,545 S,586,207 METHODS AND ASSEMBL FOR PACKAGING ELECTR DEVICES AND FOR COUPLING OPTICAL FOR PACKAGING ELECTR DEVICES AND FOR COUPLING OPTICAL CIRCULAR GRATING LASI CIRCULAR GRATING LASI CIRCULAR GRATING LASI CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODUL USING NON EQUAL POWER SPLITTIN THEMPERATURE O8/242,653 S,483,547 SEMICONDUCTOR LASE STRUCTURE FOR IMPROV STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE	RO2788	THE THERMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH		08/118,273	5,345,459	·		EMISSION WAVELENGTH OF
ASSEMBLIES FOR PACKAGING ELECTR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES RO2817 CIRCULAR GRATING LASER OFFICAL MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING RO2879 SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE AND ASSEMBLIES FOR PACKAGING ELECTR DEVICES AND FOR COUPLING OPTICAL FOR CIRCULAR GRATING LASI CIRCULAR GRAT	RO2799	LASER WITH INDEX COUPLING	US	08/170,074	5,452,318			1
RO2875 CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING RO2879 SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE CHIRP CONTROL OF A MACH ZEHNDER CONTROL OF A MACH ZEHNDER OPTICAL MODUL USING NON EQUAL POWER SPLITTING SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES AMBIENT TEMPERATURE	RO2809	ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE		08/158,545	5,586,207			METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES
MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING RO2879 SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE MACH ZEHNDER ZEHNDER OPTICAL MODUL USING NON EQUAL POWER SPLITTIN SEMICONDUCTOR LASE STRUCTURE FOR IMPROV STABILITY OF THE THRESHOLD CURRENT W RESPECT TO CHANGES AMBIENT TEMPERATURE	RO2817		US	08/158,543	5,448,581			CIRCULAR GRATING LASERS
STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE STRUCTURE FOR IMPROV. STABILITY OF THE THRESHOLD CURRENT W RESPECT TO CHANGES AMBIENT TEMPERATURE	RO2875	MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER	US	08/450,841	5,524,076			CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING
		STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT		08/242,653	5,483,547			THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT
HO2956 SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT SHIFT SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	RO2956	MODULATOR WITH A 2-2	GB	9513146.2	2 302 738			SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT
RO2956 SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT SEMICONDUCTOR MODULATOR MODULATOR WITH A 2-2 SHIFT		MODULATOR WITH A 2-2	JP	8-188293				SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT
RO2956 SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT CA 2,176,099 2,176,099 SEMICONDUCTOR MODULATOR WITH A SHIFT		MODULATOR WITH A 2-2	CA	2,176,099	2,176,099			SEMICONDUCTOR MODULATOR WITH A SHIFT

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RO2956		US		5,694,504	#Status		SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT
RO2969	P METHOD OF ETCHING PATTERNS IN III-V MATERIAL WITH ACCURATE DEPTH CONTROL	US	08/450,839	5,567,659			METHOD OF ETCHING PATTERNS IN III-V MATERIAL WITH ACCURATE DEPTH CONTROL
RO2974	MULTI WAVELENGTH GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY	US	08/413,555	5,536,085			MULTI WAVELENGTH GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	CA	2,209,455				COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	EP	97304743.4				COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	JΡ	9-174942				COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	US	08/675,757	5,799,119			COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO3007	BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKING LAYER	US	08/728,991	6,028,875			BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKI G LAYER
RO3015	THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS	GB	9700985.6	2 309 335			THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS
RO3015	THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS	JP	9-009795				THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS
RO3015	THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS	US	08/977,371	5,960,014			THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS
RO3066	LASER DIODE AND METHOD OF FABRICATION THEREOF	US	09/093,399	6,151,347			LASER DIODE AND METHOD OF FABRICATION THEREOF

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RO3090	CONFIGURABLE CHIRF MACH-ZEHNDER OPTICAL MODULATOR		2,220,240	2,220,240	Status	Dept No. 4	CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	1	97308615.0				CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	US	08/745,168	5,778,113			CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	US	09/057,602	5,991,471			CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3092	POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE	us	08/686,355	5,777,793			POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	CA	2,209,558				WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	EP	97111630.6	0 818 859	Nat'l Phase Filed		WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	US	08/680,284	5,825,792			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	JP	9-186204				WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	GB	97111630.6	0 818 859	·		WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	DE	97111630.6	697 11 126.1			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	FR	97111630.6	0 818 859	·		WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS

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RO3478	TWO SECTION COMPLE COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASE WITH ENHANCED WAVELENGTH TUNING RANGE	R	98307439.4		Satus	Sales Depi		TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
RO3478	TWO SECTION COMPLEY COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASEF WITH ENHANCED WAVELENGTH TUNING RANGE		10-264323					TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
RO3478	TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASEF WITH ENHANCED WAVELENGTH TUNING RANGE		08/933,529	5,936,994				TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
RO3479	DISTRIBUTED FEEDBACK SEMICONDUCTOR LASEF WITH GAIN MODULATION		08/953,015	6,026,110				DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH GAIN MODULATION
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS	EP	98310111.4				· ·	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS	JP	10-366380					SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS	US	08/998,071	6,104,739				SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3746	ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION	US	08/994,453	5,869,398				ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	wo	PCT/CA99/01067				-	A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	CA	2,310,604					A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	EP	99973441.1					A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	JP	2000-588867					A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER

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RO4144	COMPACT PROGRAMMABLE MATRIX OF STRONGLY COMPLEX COUPLED DFE LASERS FOR WIDE AND CONTINUOUS SINGLE WAVELENGTH		09/209,860	6,201,824			STRONGLY COMPLEX COUPLED DFB LASERS SERIES
RO4324	CONTINUOUSLY TUNABLE HIGH REPETITION RATE SHORT PULSE GENERATION USING DUAL MODE HIGHLY GAIN-COUPLED DFB LASER DIODES	US	09/213,088				GENERATION OF SHORT OPTICAL PULSES USING STRONGLY COMPLEX COUPLED DFB LASERS
RO4416	VARIABLE OPTICAL ATTENUATOR	US	09/388,628	6,246,826			VARIABLE OPTICAL ATTENUATOR WITH PROFILED BLADE
RO4504	ACTIVE REFLECTION MODULATOR	US	09/409,036				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR		PCT/CA00/00856	-	Nat'l Phase Filed		COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	CA	2,351,381				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	ĒΡ	947728.2				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	JP	2001-527411				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM

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No-	DISCUSCIE III	راف	serial No.		SubStants — அறிகம்நூம்
10163ID		CA			SLOTTED MONOLITHIC OPTICAL WAVEGUIDES
10163ID	OPTICAL WAVEGUIDES	EP	304657		PHASE ADJUSTER USING SLOTTED, CONCATENATED WAVEGUIDES AND THERMO- OPTIC OR ELECTRO-OPTIC INSERTS
10163ID	SLOTTED MONOLITHIC OPTICAL WAVEGUIDES	US	09/346,320	6,424,755	SLOTTED MONOLITHIC OPTICAL WAVEGUIDES
11550RC	HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH	CA	2,355,450	·	HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH
11550RC	HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH	US	09/672,703		HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH
12801AU	FIBRE OPTIC CIRCULATOR	EP	96940631.3		FIBRE OPTIC CIRCULATOR
12801AU	FIBRE OPTIC CIRCULATOR	US	08/942,601	6,014,475	FIBRE OPTIC CIRCULATOR
	OPTICAL FILTERING METHOD AND DEVICE		2,318,674		OPTICAL FILTERING METHOD AND DEVICE
12802AU	OPTICAL FILTERING METHOD AND DEVICE	US	09/660,147	6,466,704	OPTICAL FILTERING METHOD AND DEVICE
12802AU	OPTICAL FILTERING METHOD AND DEVICE	wo	PCT/AU00/00735		OPTICAL FILTERING METHOD AND DEVICE
12803AU	REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	CA	2,313,311		REFLECTIVE NON RECIPROCAL OPTICAL DEVICE
12803AU	REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	EP	202289.5		REFLECTIVE NON RECIPROCAL OPTICAL DEVICE

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12803A	REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	US	09/345,027	6,263,13	1	REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE
12803A	U REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	US	09/610,601	6,415,07	7	REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE
12804A	U WAVELENGTH DEPENDENT ISOLATOR	CA	10/129828		Nat'l Phas Filed	e WAVELENGTH DEPENDENT ISOLATOR
12804A	ISOLATOR		PCT/AU00/01380		Nat'l Phas	WAVELENGTH DEPENDENT ISOLATOR
12804A	ISOLATOR	wo	PCT/AU00/01380		Nat'l Phase	WAVELENGTH DEPENDENT ISOLATOR
13240AI	POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE	US	09/736,095			POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE
1408110	FIBRE OPTICAL COMPONENT	T US	09/888,888			FIBRE OPTICAL COMPONENT
14669Al	VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE	US	10/218,267			VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE
15087ID	AN OPTICAL GRATING DEVICE	US	10/109,916			AN OPTICAL GRATING DEVICE
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	DE	95308065.2	695 27 251.9		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	EP	95308065.2	0 713 109	Nat'l Phase Filed	WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	FR	95308065.2	0 713 109		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	GB	9521916.8	2 295 245		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	JP	293047/1995			WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	US	08/557,857	5,703,976		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0226	OPTICAL WAVEGUIDE GRATINGS	GB	9318670.8	2 281 787		OPTICAL WAVEGUIDE GRATINGS
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	DE	95308201.3	695 25 223.2		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	EP	95308201.3	0 713 110	Nat'l Phase Filed	OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	FR	95308201.3	0 713 110		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	GB	9523489.4	2 295 247		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	US	08/558,709	5,638,473		OPTICAL WAVEGUIDE GRATING FILTER
D0309	BRAGG GRATINGS IN WAVEGUIDES	US	08/647,795	5,730,888		BRAGG GRATINGS IN WAVEGUIDES
D0355	ALL-FIBRE OPTICAL FILTER	DE	96302352.8	696 22 778.9		OPTICAL NOTCH FILTER MANUFACTURE
D0355	ALL-FIBRE OPTICAL FILTER	EP	96302352.8	0 736 784	Nat'l Phase Filed	OPTICAL NOTCH FILTER MANUFACTURE

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ID0355	ALL-FIBRE OPTICAL FILTER	FR	96302352.8	0 736 78	4	OPTICAL NOTCH FILTER MANUFACTURE
ID0355	ALL-FIBRE OPTICAL FILTER	GB	96302352.8	0 736 784	,	
						OPTICAL NOTCH FILTER MANUFACTURE
ID0355				5,708,740		ALL-FIBRE OPTICAL FILTER
ID0421	PLANAR WAVEGUIDES	US	08/842,021	5,904,491		PLANAR WAVEGUIDES
ID0423	PLANAR WAVEGUIDE CLADDING	US	08/842,022	5,885,881		PLANAR WAVEGUIDE CLADDING
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	CA	2,241,189			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	DE	97906822.8	697 09 330.1		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	EP	97906822.8	0 891 570	Nat'l Phase Filed	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	FR	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	GB	9605320.2	2 311 145		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	GB	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
1D0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	ŝΤ	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	JP	532348/1997			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	US	09/101,276			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	wo	PCT/GB97/00606		Nat'l Phase Filed	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	CA	2,239,118			WAVEGUIDE PAIR WITH CLADDING
ID0449	WAVEGUIDE PAIR WITH CLADDING	DE	97900292	697 02 299.4	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	EP	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	FR	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
1D0449	WAVEGUIDE PAIR WITH CLADDING	GB	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY

206	es Disalostica	, Gi	y Samin	a- Raeni	lo Sidistii	S) Apple the tile.
ID04	49 WAVEGUIDE PAIR WIT CLADDING	Н	97900292	0 873 5	31 Nat'l Phas Filed	METHOD OF PRODUCING A CLADDED WAVEGUI PAIR ASSEMBLY
ID04	49 WAVEGUIDE PAIR WITH CLADDING	Н ЈР	524974/199)7		WAVEGUIDE PAIR WITH CLADDING
ID04	WAVEGUIDE PAIR WITH CLADDING	1 US	09/091,257	6,044,19	92	WAVEGUIDE PAIR WITH CLADDING
ID04	WAVEGUIDE PAIR WITH CLADDING	1 WC	PCT/GB97/000	040	Nat'l Phase Filed	WAVEGUIDE PAIR WITH CLADDING
ID050	MANUFACTURE OF PLAN, WAVEGUIDE COMPONEN WITH DISPERSIVE ELEMENTS AND FINE LOC REF. INDEXCON.	TS	2,211,244			OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS
ID050	MANUFACTURE OF PLANA WAVEGUIDE COMPONENT WITH DISPERSIVE ELEMENTS AND FINE LOCA REF. INDEXCON.	rs	9715185.6	2 316 185	5	MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.
ID0509	WAVEGUIDE COMPONENT WITH DISPERSIVE ELEMENTS AND FINE LOCA REF. INDEXCON.	T.	209343/97	-		MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.
ID0509	MANUFACTURE OF PLANA WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCA REF. INDEXCON.	S	08/896,092	6,115,518		OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS
1D0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	CA	2,282,939			OPTICAL EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	DE	99306728.9	699 01 419.0		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	EP	99306728.9	1 009 078	Nat'l Phase Filed	OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	FR	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	GB	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
1D0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	IT	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	US	09/209,387	6,321,000		OPTICAL EQUALIZER
ID8550	OPTICAL FIBRES	GB	8230675	2 129 152		OPTICAL FIBRES

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	Deebsurerite	روق	Salainto	Partitle	SurSaits Jupilearan Tile
ID9170	BEAM SPLITTER/COMBERS	CA	500,513	1,288,267	BEAM SPLITTER/COMBERS
ID9170	BEAM SPLITTER/COMBERS	GB	8503506	2 170 920	BEAM SPLITTER/COMBERS
ID9170	BEAM SPLITTER/COMBERS	US	06/819,125	4,756,589	BEAM SPLITTER/COMBERS
ID9441	DIRECTIONAL COUPLER	DE	378 25 37.2	378 25 37.2	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	FR	87302418.6	0 246 737	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	GB	8612660	2 190 762	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	JР	118687/87	2022576	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	us	07/032,783	4,801,185	DIRECTIONAL COUPLER
ID9579	GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS	GB	8716382	2 207 254	GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS
ID9730	DOPED ELEMENTS	GB	8820848.3	2 222 400	DOPED ELEMENTS
ID9758	"OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING"	GB	8926061.6	2 238 396	*OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING*
RO2922	POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ON BIREFRINGENCE COMPENSATION	US	08/329,923	5,488,679	POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ONBIREFRINGENCE COMPENSATION